

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Michael Berman et. al.

Serial No. : 10/628 601

Filed : July 28, 2003

For : Method And Apparatus For  
Detecting Backside Contamination  
During Fabrication Of A  
Semiconductor Wafer

§ Group Art Unit : 2812

§ Examiner : Lai, Olivia

§ Atty Docket : 31692-70168 / 01-  
965/1D§ I hereby certify that this correspondence is being deposited  
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Connie Del Castillo11/10/03 Connie del Castillo  
Date Signature

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached form, copies of which are attached, may be material to examination of above-identified application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR 1.56 and 1.97.

It is requested that the information disclosed herein be made of record in the application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

If it is determined that any additional fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 12-2252.

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Date: 11/10/03

Respectfully submitted,



Timothy Croll

Reg. No. 36,771

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PTO/SB/08A (10-06) Approved for use through 10/31/2009. GPO: 08-051-0031

Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of

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### Complete if Known

Application Number	
Filing Date	July-28, 2003
First Named Inventor	Michael Berman
Group Art Unit	2812
Examiner Name	Olivia Luk
Attorney Docket No.	31692-70168 / 01-985/1D

U.S. PATENT DOCUMENTS				
Examiner Initials	Cite No.	U.S. Patent Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
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		5,773,989	Edelman et al.	06-30-1998
		5,963,313	Hiatt et al.	10-03-1999
		5,972,725	Wollesen et al.	10-26-1999
		6,060,715	England et al.	05-09-2000
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Examiner signature		Date considered
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